

Search Notes

Application/Control No.

10/779,400

Examiner

Raymond Phan

Applicant(s)/Patent under
Reexamination

IWAMURA, RYUICHI

Art Unit

2111

SEARCHED

Class	Subclass	Date	Examiner
710	305-308, 313-317, 62-64, 58-61	2/10/2006	RP
709	201-203	2/12/2006	RP

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
710 (Text search), 709 (text search) 710/307 (text search) EAST	2/13/2006	RP